

| L Number | Hits | Search Text | DB | Time stamp |
|----------|-------|--|---|------------------|
| 25 | 2 | ("1930905" "2137852").PN. | USPAT | 2004/11/03 08:27 |
| 26 | 14 | 4546658.URPN. | USPAT | 2004/11/03 08:27 |
| 89 | 2 | ("5578766").PN. | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/11/03 08:52 |
| 90 | 2 | ("6450040").PN. | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/11/03 09:11 |
| 91 | 9 | ("3145563" "3251222" "3355935" "3582690" "3585415" "3761784" "4480488" "5770803" "5886543").PN. | USPAT | 2004/11/03 08:52 |
| 92 | 4 | 3145563.URPN. | USPAT | 2004/11/03 09:07 |
| 93 | 8 | ((("6091022") or ("5869766") or ("5760675") or ("5939817") or ("4701660") or ("3088323") or ("4556814") or ("4419598")).PN. | USPAT | 2004/11/03 09:20 |
| 94 | 7 | 4419598.URPN. | USPAT | 2004/11/03 09:15 |
| 95 | 6 | ("2311617" "3283590" "3417322" "3492513" "3739201" "3805601").PN. | USPAT | 2004/11/03 09:17 |
| 96 | 89951 | 310/\$7.ccls. | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/11/03 09:20 |
| 97 | 431 | 310/\$7.ccls. and (force near3 (sens\$4 evaluat\$5 estimat\$5 cell rate comput\$5 detect\$4 test\$4 meter gauge transducer measur\$4 indicat\$4 identif\$4 monitor\$4 determina\$4)).clm. | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/11/03 09:21 |
| 98 | 51 | (310/\$7.ccls. and (force near3 (sens\$4 evaluat\$5 estimat\$5 cell rate comput\$5 detect\$4 test\$4 meter gauge transducer measur\$4 indicat\$4 identif\$4 monitor\$4 determina\$4)).clm. | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/11/03 09:25 |
| 99 | 19 |) and (semiconductor substrate).clm. ((310/\$7.ccls. and (force near3 (sens\$4 evaluat\$5 estimat\$5 cell rate comput\$5 detect\$4 test\$4 meter gauge transducer measur\$4 indicat\$4 identif\$4 monitor\$4 determina\$4)).clm. | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/11/03 09:26 |
| 100 | 19 |) and (semiconductor substrate).clm.) and electrode.clm. ("2408816" "3714476" "3801838" "3948089" "4480488" "4512431" "4604544" "4816713" "5371472" "5537883" "5682000" "5739626" "5747671" "5777231" "5777239" "5852245" "5886456" "6271621" "6396200").PN. | USPAT | 2004/11/03 09:35 |
| 101 | 0 | 6617764.URPN. | USPAT | 2004/11/03 09:39 |
| 142 | 2 | ("4546658").PN. | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/11/03 11:18 |
| 143 | 1 | ((("4546658").PN.) and (substrate semiconductor silicon) | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/11/03 11:19 |
| - | 2518 | (73/760,763,774,781,777,862.381,862.474,862.68,862.621).CCLS. | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/11/02 09:40 |
| - | 311 | ((73/760,763,774,781,777,862.381,862.474,862.68,862.621).CCLS.) and (force near3 (sens\$4 evaluat\$5 estimat\$5 cell rate comput\$5 detect\$4 test\$4 meter gauge transducer measur\$4 indicat\$4 identif\$4 monitor\$4 determina\$4)).clm. | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/11/03 09:20 |

| | | | | |
|---|--------|---|---|------------------|
| - | 56 | (((73/760,763,774,781,777,862.381,862.474,862.68,862.621).CCLS.) and (force near3 (sens\$4 evaluat\$5 estimat\$5 cell rate comput\$5 detect\$4 test\$4 meter gauge transducer measur\$4 indicat\$4 identif\$4 monitor\$4 determina\$4)).clm. | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/11/03 09:25 |
| - | 16 |) and (semiconductor substrate).clm. (((73/760,763,774,781,777,862.381,862.474,862.68,862.621).CCLS.) and (force near3 (sens\$4 evaluat\$5 estimat\$5 cell rate comput\$5 detect\$4 test\$4 meter gauge transducer measur\$4 indicat\$4 identif\$4 monitor\$4 determina\$4)).clm. | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/11/03 09:26 |
| - | 13 |) and (semiconductor substrate).clm.) and electrode.clm. ((((73/760,763,774,781,777,862.381,862.474,862.68,862.621).CCLS.) and (force near3 (sens\$4 evaluat\$5 estimat\$5 cell rate comput\$5 detect\$4 test\$4 meter gauge transducer measur\$4 indicat\$4 identif\$4 monitor\$4 determina\$4)).clm. | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/11/02 09:41 |
| - | 6 |) and (semiconductor substrate).clm.) and electrode.clm.) and current ((((73/760,763,774,781,777,862.381,862.474,862.68,862.621).CCLS.) and (force near3 (sens\$4 evaluat\$5 estimat\$5 cell rate comput\$5 detect\$4 test\$4 meter gauge transducer measur\$4 indicat\$4 identif\$4 monitor\$4 determina\$4)).clm. | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/11/02 09:49 |
| - | 7 |) and (semiconductor substrate).clm.) and electrode.clm.) and current.clm. ("3351786" "4320664" "4703658" "4771639" "4833929" "4993266" "5142914").PN. | USPAT | 2004/11/02 09:45 |
| - | 3 | 5349873.URPN. | USPAT | 2004/11/02 09:48 |
| - | 7 | ((((73/760,763,774,781,777,862.381,862.474,862.68,862.621).CCLS.) and (force near3 (sens\$4 evaluat\$5 estimat\$5 cell rate comput\$5 detect\$4 test\$4 meter gauge transducer measur\$4 indicat\$4 identif\$4 monitor\$4 determina\$4)).clm. | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/11/02 10:03 |
| - | 10 |) and (semiconductor substrate).clm.) and electrode.clm.) and current) not ((((73/760,763,774,781,777,862.381,862.474,862.68,862.621).CCLS.) and (force near3 (sens\$4 evaluat\$5 estimat\$5 cell rate comput\$5 detect\$4 test\$4 meter gauge transducer measur\$4 indicat\$4 identif\$4 monitor\$4 determina\$4)).clm. | | |
| - | 4 |) and (semiconductor substrate).clm.) and electrode.clm.) and current.clm.) (("5341688") or ("4833929") or ("4680606") or ("4419598")).PN. | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/11/02 10:04 |
| - | 175813 | kabushiki.as. | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/11/02 11:18 |
| - | 2438 | kabushiki.as. and (force pressure transducer).ti. | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/11/02 11:19 |
| - | 124 | (kabushiki.as. and (force pressure transducer).ti.) and semiconductor.ab. | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/11/02 11:20 |
| - | 150 | (kabushiki.as. and (force pressure transducer).ti.) and electrode.ab. | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/11/02 11:20 |

| | | | | |
|---|-----|--|--|------------------|
| - | 28 | ((kabushiki.as. and (force pressure transducer).ti.) and semiconductor.ab.) and electrode.ab. | USPAT; US-PGPUB; EPO; JPO; DERWENT USPAT | 2004/11/02 11:42 |
| - | 7 | ("3351786" "4320664" "4703658" "4771639" "4833929" "4993266" "5142914").PN. | | 2004/11/02 11:27 |
| - | 2 | ("3149488" "4833929").PN. | USPAT | 2004/11/02 11:28 |
| - | 19 | 4993266.URPN. | USPAT | 2004/11/03 11:18 |
| - | 2 | ("4993266").PN. | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/11/02 12:05 |
| - | 105 | ((73/760,763,774,781,777,862.381,862.474,862.68,862.621).CCLS.) and electrode near5 ((top face end oppos\$5) and (bottom face other end oppos\$5)) | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/11/02 12:06 |
| - | 40 | ((73/760,763,774,781,777,862.381,862.474,862.68,862.621).CCLS.) and (force near3 (sens\$4 evaluat\$5 estimat\$5 cell rate comput\$5 detect\$4 test\$4 meter gauge transducer measur\$4 indicat\$4 identif\$4 monitor\$4 determina\$4)).clm. | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/11/02 12:59 |
| - | 16 |) and electrode near5 ((top face end oppos\$5) and (bottom face other end oppos\$5)) (((73/760,763,774,781,777,862.381,862.474,862.68,862.621).CCLS.) and (force near3 (sens\$4 evaluat\$5 estimat\$5 cell rate comput\$5 detect\$4 test\$4 meter gauge transducer measur\$4 indicat\$4 identif\$4 monitor\$4 determina\$4)).clm. | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/11/02 12:07 |
| - | 24 |) and (semiconductor substrate).clm.) and electrode near5 ((top face end oppos\$5) and (bottom face other end oppos\$5)) (((73/760,763,774,781,777,862.381,862.474,862.68,862.621).CCLS.) and (force near3 (sens\$4 evaluat\$5 estimat\$5 cell rate comput\$5 detect\$4 test\$4 meter gauge transducer measur\$4 indicat\$4 identif\$4 monitor\$4 determina\$4)).clm. | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/11/02 13:01 |
| - | 6 |) and electrode near5 ((top face end oppos\$5) and (bottom face other end oppos\$5))) NOT (((73/760,763,774,781,777,862.381,862.474,862.68,862.621).CCLS.) and (force near3 (sens\$4 evaluat\$5 estimat\$5 cell rate comput\$5 detect\$4 test\$4 meter gauge transducer measur\$4 indicat\$4 identif\$4 monitor\$4 determina\$4)).clm. | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/11/03 08:50 |
| - | 14 |) and (semiconductor substrate).clm.) and electrode near5 ((top face end oppos\$5) and (bottom face other end oppos\$5))) and (semiconductor) 4546658.URPN. | USPAT | 2004/11/02 13:06 |
| - | 19 | ("3614485" "3634787" "4050530" "4144747" "4215570" "4294105" "4372173" "4546658" "4642508" "4789804" "5023503" "5232063" "5362929" "5684276" "5852229" "5869763" "5946795" "5962786" "6080939").PN. | USPAT | 2004/11/02 13:09 |